

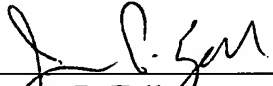


IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicants: Kim  
Serial No.: 10/032,687  
Filed: December 28, 2001  
For: METHOD OF FORMING  
WIRING IN SEMICONDUCTOR  
DEVICES  
Group Art Unit: 2822  
Examiner: Maria F. Guerrero

I hereby certify that this paper (or fee) is being  
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D.C. 20231

January 15, 2003

  
James P. Zeller  
Reg. No. 28,491

REQUEST FOR APPROVAL OF DRAWING CHANGES

Commissioner for Patents  
Washington, DC 20231

Sir:

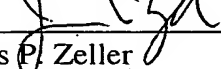
Please enter the following changes to the drawings as indicated in red on the attached  
copy thereof. Specifically, please label Figs. 1A-1D and Fig. 3 with the legend "Prior Art"  
and add new drawings Figs. 4A-4D.

APPROVED  
MG  
3-31-03

January 15, 2003

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN

By:   
James P. Zeller  
Reg. No. 28,491  
Attorneys for Applicants

6300 Sears Tower  
233 South Wacker Drive  
Chicago, Illinois 60606-6357  
(312) 474-6300

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Drawings  
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